Status update of MCC connectors



L. Andricek(1), I. Garcia (2), P. Gomis (2), C. Marinas (3), M. Perelló (2), M.A. Villarejo (2), M. Vos (2)



Outline

- 1 Introduction
- 2 MCC optimization
- 3 Schedule
- 4 Summary



Introduction



Micro-channel pattern in handle wafer



Inlet and outlet: ~380 x 340 μm



Introduction



• More information is available in: https://arxiv.org/pdf/1604.08776v2.pdf



MCC optimization

- Improvements:
 - Microchannels new layout
 - Reduction of material budget in connectors
 - Performance connectors material
 - Automatization and repeteability of gluing process
 - Mechanical performance comparison between single and double ladder



5

MCC optimization: layout





MCC optimization: layout



New mcc layout have been manufactured:

- Optimized layout for mcc: simulations predict better performance
- Mcc along all the heat sources
- Same lab. experiments are expected







SED

AIDA2020 April 4th 2017, Paris

M.A. Villarejo Bermúdez

MCC optimization: connector





AIDA2020 April 4th 2017, Paris

8

MCC optimization: pressure test



50 bar achieved



AIDA2020 April 4th 2017, Paris

M.A. Villarejo Bermúdez

MCC optimization: pressure test





MCC optimization: tensile strenght



Different radiations levels

Two type of radiation:

- Neutrons
- X-Rays















AIDA2020 April 4th 2017, Paris







AIDA2020 April 4th 2017, Paris

Schedule





Summary

- Microchannels new layout designed and manufactured
- Gluing repeatability system is on its final testing stage
- Optimization (material budget) and validation (pressure, radiation hardness) of 3D printed connector almost done: machined connectors prototypes are ongoing
- New mcc layout will be tested very soon
- It is possible to reduce more the material budget achieving better mechanical performance



Back up



M.A. Villarejo Bermúdez





Anemometer





AIDA2020 April 4th 2017, Paris



















AIDA2020 April 4th 2017, Paris